

## [IT-13. Focused ion beam microscopy and techniques](#)

10 September, 16:45 - 18:45 / 11 September, 16:30 - 18:30

### **IT-13-P-1477**

#### **Development of Cryo-FIB technique for the structural characterization of liquid samples**

Presenting author: **Tsuchiya M.**

*Authors: Tsuchiya M., Iwahori T., Morikawa A., Nagakubo Y.*

### **IT-13-P-1484**

#### **Finding the needle in the haystack: FIB-SEM combined with array tomography to achieve higher Z-resolution in selected areas**

Presenting author: **Wacker I. U.**

*Authors: Wacker I. U., Bartels C., Grabher C., Schertel A., Schröder R. R.*

### **IT-13-P-1517**

#### **Cross sectional sample preparation of nanowires for TEM analysis using FIB**

Presenting author: **Lenrick F.**

*Authors: Lenrick F., Ek M., Jacobsson D., Wallenberg L. R.*

### **IT-13-P-1667**

#### **Method For Improving FIB Prepared TEM Samples By Very Low Energy Ar+ / Xe+ Ion Mill Polishing**

Presenting author: **Kauffmann Y.**

*Authors: Kauffmann Y., Cohen-Hyams T., Kalina M., Kaplan W. D.*

### **IT-13-P-1712**

#### **Sample preparation using Xenon IC-Plasma FIB: benefits and problems.**

Presenting author: **Audoit G**

*Authors: Audoit G, Estivill R, Mariolle D, Blot X, Grenier A, Barnes J P, Cooper D*

### **IT-13-P-1838**

#### **FOCUSED ION BEAM LITHOGRAPHY OF SUBWAVELENGTH PHOTONIC 3D-CHIRAL STRUCTURES**

Presenting author: **Artemov V. V.**

*Authors: Artemov V. V., Rogov O. Y., Gorkunov M. V.*

### **IT-13-P-1861**

#### **Measurement of TEM lamella thickness and Ga implantation in the FIB**

Presenting author: **Hiscock M.**

*Authors: Lang C., Hiscock M., Dawson M., Hartfield C., Statham P. J.*

### **IT-13-P-1915**

#### **Advances in ex situ lift out**

Presenting author: **Giannuzzi L. A.**

*Authors: Giannuzzi L. A.*

### **IT-13-P-1929**

#### **Influence of FIB milling on the determination of sp<sup>2</sup>/sp<sup>3</sup> ratio of carbon materials**

Presenting author: **Zhang X.**

*Authors: Zhang X., Schneider R., Müller E., Mee M., Meier S., Gumbsch P., Gerthsen D.*

### **IT-13-P-2055**

#### **Optimized Detection Limits in FIB-SIMS by Using Reactive Gas Flooding and High Performance Mass Spectrometers**

Presenting author: **Eswara Moorthy S.**

*Authors: Wirtz T., Dowsett D., Philipp P., Eswara Moorthy S.*

### **IT-13-P-2068**

#### **Characterization of carbonaceous contamination and the cleaning capability of atomic hydrogen during focused ion beam processing**

Presenting author: **Steiger-Thirsfeld A.**

*Authors: Steiger-Thirsfeld A., Basnar B., Tomastik C., Pongratz P., Lugstein A.*

### **IT-13-P-2075**

#### **Nanopatterning Plasmonic Structures Using Focused Ion Beam and E-Beam Lithography**

Presenting author: **Cohen Hyams T.**

*Authors: Cohen Hyams T., Spektor G., Gal L., Orenstein M.*

### **IT-13-P-2432**

#### **Optimization of the sample preparation method for semiconductor dopant contrast observation with SEM**

Presenting author: **Druckmüllerová Z.**

*Authors: Druckmüllerová Z., Kolíbal M., Vystavěl T., Šíkola T.*

### **IT-13-P-2440**

#### **Channeling contrast: a cost effective alternative to EBSD orientation mapping in scanning focused probe instruments (SEM/FIB) ?**

Presenting author: **Langlois C. T.**

*Authors: Langlois C. T., Yuan H., Douillard T., Van de Moortele B., Descamps-Mandine A., Blanchard N., Epicier T.*

### **IT-13-P-2481**

#### **Cryogenic FIB Lift-out as a preparation method for damage-free soft matter TEM imaging**

Presenting author: **Parmenter C. D.**

*Authors: Parmenter C. D., Fay M. W., Hartfield C., Amdor G., Moldovan G.*

### **IT-13-P-2485**

#### **Characterization of Ga<sup>+</sup> FIB Damage in Electron Beam Induced Deposited Platinum, Tungsten and Carbon Chemistries for In-situ S/TEM Sample Preparation**

Presenting author: **Van Leer B.**

*Authors: Van Leer B., Landin T., Wall D., Roussel L.*

#### **IT-13-P-2498**

##### **FIB/SEM tomography for 3D visualization of virus infected fibroblasts with TEM-like resolution.**

Presenting author: **Villinger C.**

*Authors: Villinger C., Neusser G., Kranz C., Walther P., Mertens T.*

#### **IT-13-P-2590**

##### **Enabling future Nanotomography and Nanofabrication with Crossbeam technology**

Presenting author: **Schulmeyer I.**

*Authors: Schulmeyer I., Kienle M.*

#### **IT-13-P-2616**

##### **In situ FIB/SEM micro-compression tests of layered crystals**

Presenting author: **Schweizer P.**

*Authors: Schweizer P., Niekel F., Butz B., Spiecker E.*

#### **IT-13-P-2701**

##### **High performance nanomachining using the new analytical FIB-SEM system**

Presenting author: **Jiruše J.**

*Authors: Jiruše J., Havelka M., Haničinec M., Polster J., Hrnčíř T.*

#### **IT-13-P-2704**

##### **Focused ion beam patterning of boron-doped diamond electrodes: Influence of patterning parameters on the heterogeneous electron transfer behavior**

Presenting author: **Eifert A.**

*Authors: Eifert A., Langenwalter P., Higl J., Lindén M., Nebel C., Mizaikoff B., Kranz C.*

#### **IT-13-P-2724**

##### **Novel strategies towards faster and smoother FIB cross-sectioning**

Presenting author: **Hrnčíř T.**

*Authors: Hrnčíř T., Dluhoš J., Haničinec M., Hrachovec V.*

#### **IT-13-P-2741**

##### **Ultra-Fast Three Dimensional Microanalysis Using the Scanning Electron Microscope Equipped with Xenon Plasma Focused Ion Beam**

Presenting author: **Dluhoš J.**

*Authors: Dluhoš J., Petrevec M., Peřina P., Reinauer F., Kopeček J., Hrnčíř T., Jiruše J.*

#### **IT-13-P-2874**

##### **Targeted 3D-CLEM workflow on cultured cells**

Presenting author: **Steyer A. M.**

*Authors: Steyer A. M., Schieber N. L., Duishoev N., Pepperkok R., Kirmse R., Schertel A., Schwab Y.*

#### **IT-13-P-2936**

##### **Characterisation of the FIB Induced Damage in Diamond**

Presenting author: **Rubanov S.**

*Authors: Rubanov S., Suvorova A.*

**IT-13-P-2986**

**High quality site specific TEM cross section preparation of structured materials**

Presenting author: **Graff A.**

*Authors: Graff A., Hübner S., Simon-Najasek M., Altmann F.*

**IT-13-P-3033**

**About the accuracy of post-mortem alignment methods in FIB/SEM nano-tomography**

Presenting author: **Yuan H.**

*Authors: Yuan H., Van de Moortèle B., Epicier T.,*

**IT-13-P-3258**

**FIB as Fabrication Tool for Advanced Analytical Infrared Sensing Schemes**

Presenting author: **Neusser G.**

*Authors: Sieger M., Neusser G., Schaedle T., Kranz C., Mizaikoff B.*

**IT-13-P-3393**

**USING THE FOCUSED ION BEAM MICROSCOPE TO DEVELOP DIFFRACTION GRATINGS FOR QUANTUM WELL INFRARED PHOTODETECTORS**

Presenting author: **Schmidt W.**

*Authors: Rodrigues W., Schmidt W.*

**IT-13-P-5975**

**LIFE CELL IMMUNOGOLD LABELLING OF RNA POLYMERASE II visualized by Focused Ion Beam Scanning Electron Microscopy (SEM-FIB)**

Presenting author: **Spehner D.**

*Authors: Orlov I., Schertel A., Zuber G., Drillien R., Weiss E., Schultz P., Spehner D.*

**IT-13-P-6027**

**Structural characterization of hybrid-organic nanocomposites via focus ion beam preparation and electron microscopy**

Presenting author: **Ankah G. N.**

*Authors: Ankah G. N., Büchele P., Tedde S. F., Adam J., Torrents O., Pfaff M., Poulsen K., Koch M., Gimmler C., Schmidt O., Kraus T.*

**IT-13-P-6033**

**Structural and mechanical characterization of human dental tissues across multiple scales at the Oxford Multi-Beam Laboratory for Engineering Microscopy (MBLEM)**

Presenting author: **Sui T.**

*Authors: Sui T., Ying S., Lunt A. J., Baimpas N., Landini G., Korsunsky A. M.*